# Gold Nanoparticle Synthesis using High-speed Pulsed Mixing Microfluidic Device

# Koji Sugano, Ayumi Maedomari, Yuki Tanaka, Yoshitada Isono Department of Mechanical Engineering, Kobe University

**Abstract :** For chemical syntheses in a microreactor, mixing speed is thought to be significant parameter in the case that chemical reaction speed is significant high. For gold nanoparticle synthesis process, an initial reaction has been known as a rapid reaction. Therefore, so far we have developed a microreactor for gold nanoparticle synthesis using a pulsed mixing microfluidic device with T-shaped mixing channels for high-speed mixing. In this study, we uses the novel pulsed mixing method with cross-shaped mixing channels in a microreactor to improve the mixing speed. The mixing achieved higher mixing speed than the conventional method. This study found that mixing speed of two solutions was an effective parameter for increasing particle size uniformity and that higher mixing speed achieved higher particle size uniformity.

Gold nano	article
Plasmonic	<b>Particle synthesis mechanisr</b>
roconanco	

## Microfluidic pulse mixing method

(a) Conventional T-shaped channel (b) Proposed cross-shaped channel with three inlets controlling reverse







### Mixing performance

#### Fluorescence images





#### **Fluorescence images**



- In the both cases of concentrations, we observed that the coefficient of variation of the particle diameter tended to decrease with increasing the switching frequency.
- At the HAuCl<sub>4</sub> concentrations of 1.0 mM and 10 mM, the coefficients of variation show saturation tendencies from 100 Hz and 200 Hz, respectively.
- This is because higher concentration of solutions provides higher reaction speed. At higher reaction speed, mixing speed has an effect of synthesis up to higher switching frequency.
- From these results we confirmed that the proposed method for high mixing speed is useful for uniformly sized nanoparticle synthesis.

Kobe University

NanoSmart @ Isono Labo. - (Intelligent Artifacts & Manufacturing Systems) -